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Bib Data Sheet

**CONFIRMATION NO. 4146**

SERIAL NUMBER 09/920,341	FILING DATE 08/01/2001  RULE	CLASS 356	GROUP ART UNIT 2877	ATTORNEY DOCKET NO. 5119-08301
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## APPLICANTS

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\*\* CONTINUING DATA \*\*\*\*\* *Yes SN*

This appln claims benefit of 60/222,233 08/01/2000

\*\* FOREIGN APPLICATIONS \*\*\*\*\* *None SN*

IF REQUIRED, FOREIGN FILING LICENSE GRANTED

\*\* SMALL ENTITY \*\*

\*\* 10/15/2001

Foreign Priority claimed <input type="checkbox"/> yes <input checked="" type="checkbox"/> no	STATE OR	SHEETS	TOTAL	INDEPENDENT
35 USC 119 (a-d) conditions met <input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> Met after Allowance	COUNTRY	DRAWING	CLAIMS	CLAIMS
Verified and Acknowledged Examiner's Signature <i>S. V. Sreenivasan</i> Initials	TX	52	38 <i>49</i>	4 <i>3</i>

## ADDRESS

Molecular Imprints, Inc.  
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 P.O. Box 81536  
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 78708-1536

## TITLE

Methods for high-precision gap and orientation sensing between a transparent template and substrate for imprint lithography

FILING FEE	FEES: Authority has been given in Paper	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees ( Filing )
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